

1. Transmission Electron Microscopy

- Units and unit conversion: length, angle, solid angle
 - Small-angle approximation
 - Relativistic electron wavelength
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2. Scattering and Diffraction

- Terminology: elastic/inelastic, coherent/incoherent, forward/back scattering
 - Scattering cross-section (units), mean free path
 - Two-slit interference, diffraction from single slit, Rayleigh criterion
 - Convergence & collection angles
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3. Elastic Scattering

- Wave parameters: amplitude, phase, wavelength, frequency, velocity, wave number, wave vector
 - Complex exponential form of a wave, finding magnitude squared (intensity)
 - Atomic scattering amplitude (form factor), nature of the interaction of electrons with atomic matter
 - Weak-phase-object approximation, structure factor, Bragg law
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4. Inelastic Scattering

- Inelastic scattering processes: collective excitations, X-ray emission, secondary electrons, excitons,...
 - Effects of ionization: characteristic X-ray emission, Auger electron emission
 - Bremsstrahlung: braking radiation
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5. Magnification and Electron Sources

- Ideal lens equation
 - Lateral and angular magnification
 - Brightness definition, conservation of brightness
 - Thermionic and field-emission types
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6. Electron Lenses

- Depths of field and focus
- Spherical aberration, effect on focal length, effect on image resolution
- Factors affecting practical resolution
- Principles of a magnetic electron lens, axially symmetric B-field, Lorentz force

7. Instrument Operation

- Condenser system, lateral demagnification
- Influences of C1, C2, and C3 on probe size; influence of CA on convergence angle
- Deflection lenses: beam tilt and shift
- Lens planes, back focal plane vs. image plane
- Imaging modes: bright-field, off-axis dark-field, centered dark-field

8. Vacuum Systems and TEM Holders

- Vacuum terminology: LV, HV, UHV
- Pumps: Mechanical rotary; oil diffusion, turbomolecular, ion getter
- Gauges: Pirani (thermal), Penning (ion)
- Specimen loading, tilt axes

9. Diffraction

- Direct lattice, reciprocal lattice
- Miller indices, interplanar spacing, \mathbf{g} vector
- Selected-area diffraction

Significant Figures and Round-Off Criteria for Numerical Expressions

- Reasonable number of significant figures based on information available
- Rules for rounding off

Labs

1. TEM Magnification Calibration
2. TEM Diffraction Calibration
3. TEM Analysis of Carbon Nanotubes
4. TEM Analysis of Nanoparticles
5. Individual TEM